

COMPLETE LISTING OF ALL CLAIMS

Kindly cancel claim 25 as shown in the listing of claims below. This listing of claims will replace all prior versions, and listings of claims in the application.

- 1 Claim 1. (original) A microelectromechanical apparatus comprising:
 - 2 a base;
 - 3 a flap having a portion coupled to the base so that the flap is movable out of the plane of the base from a first angular orientation to a second angular orientation;
 - 4 wherein the base has an opening that receives the flap when the flap is in the second angular orientation, the opening having one or more sidewalls, wherein at least one of the sidewalls contacts a portion of the flap such that the flap assumes an orientation substantially parallel to that of the sidewall when the flap is in the second angular orientation; and
 - 5 a sidewall electrode disposed in one or more of the sidewalls.
- 1 Claim 2. (original) The microelectromechanical apparatus of claim 1 wherein the flap further comprises a magnetically active element.
- 1 Claim 3. (original) The microelectromechanical apparatus of claim 2 wherein the magnetically active element is a magnetic material.
- 1 Claim 4. (original) The microelectromechanical apparatus of claim 2 wherein the magnetically active element is a coil.
- 1 Claim 5. (original) The microelectromechanical apparatus of claim 2 further comprising an external magnet.
- 1 Claim 6. (original) The apparatus of claim 1 wherein the flap is connected to the base by one or more flexures.
- 1 Claim 7. (previously presented) The apparatus of claim 6 wherein at least one flexure is electrically conductive.

1 Claim 8. (original) The microelectromechanical apparatus of claim 1 further comprising a
2 light-deflecting element disposed on the flap.

1 Claim 9. (original) The microelectromechanical apparatus of claim 1, wherein the sidewall
2 electrode is electrically isolated from the base.

1 Claim 10. (original) The microelectromechanical apparatus of claim 1 further comprising:
2 a voltage source coupled between the flap and the sidewall electrode to apply an
3 electrostatic force between the sidewall electrode and the flap.

1 Claim 11. (original) The apparatus of claim 10 wherein the flap contains a magnetically
2 active material and the electrostatic force between the sidewall electrode and the flap
3 is sufficient to prevent the flap from changing position in the presence of an applied
4 magnetic field.

1 Claim 12. (original) The apparatus of claim 1 further comprising:
2 an electrode disposed on the base; and
3 a voltage source coupled between the electrode in the base and the flap to apply an
4 electrostatic force between the electrode in the base and the flap.

1 Claim 13. (original) The apparatus of claims 1 where the base is made from a substrate
2 portion of an SOI (silicon-on-insulator) wafer and the flap is defined from a device
3 layer portion of the SOI wafer.

1 Claim 14. (previously presented) The apparatus of claim 6 wherein the one or more flexures
2 include one or more torsional beams.

1 Claim 15. (original) The apparatus of claim 1, further comprising one or more conductive
2 landing pads disposed on an underside of the flap wherein the one or more conductive
3 landing pads are electrically isolated from the flap.

1 Claim 16. (original) The apparatus of claim 15, wherein one or more of the conductive
2 landing pads are electrically coupled to a sidewall electrode.

1 Claim 17. (original) The apparatus of claim 15 wherein one or more of the conductive
2 landing pads is electrically coupled to the base.

1 Claim 18. (original) The apparatus of claim 1 wherein the sidewall includes a sidewall
2 electrode and one or more conductive landing pads that are electrically isolated from
3 the sidewall electrode.

1 Claim 19. (original) The apparatus of claim 18 wherein one or more of the landing pads are
2 electrically coupled to the flap.

1 Claim 20. (original) The apparatus of claim 18 wherein the sidewall electrode is electrically
2 isolated from the base.

1 Claim 21. (original) An array of one or more structures, wherein each structure comprises:
2 a base;
3 a flap having a portion coupled to the base so that the flap is movable out of the plane
4 of the base from a first angular orientation to a second angular orientation, the flap
5 containing a reflecting element;
6 wherein the base has an opening with largely vertical sidewalls, at least one of the
7 sidewalls containing an electrode, wherein the sidewalls contact a portion of the flap
8 such that the flap assumes an orientation substantially parallel to that of the sidewall
9 when the flap is in the second angular orientation.

1 Claim 22. (original) An array of claim 21 wherein one or more of the structures includes a
2 sidewall electrode disposed in one or more of the sidewalls.

1 Claim 23. (original) The array of claim 21, wherein the sidewall electrode is electrically
2 isolated from the base.

1 Claim 24. (original) An array of claim 21 wherein the array forms an optical switch.

1 Claim 25. (cancel)

1 Claim 26. (cancel)